•	arch No	

Application/Control No.	Applicant(s)/Patent und Reexamination	Applicant(s)/Patent under Reexamination	
10/622,506	CHIANG, JOHNSON		
Examiner	Art Unit		
David M. Fenstermacher	3682		

	SEARCHED			
Class	Subclass	Date	Examiner	
74	490.01	·		
	490.02			
	490.03			
	490.05			
901	2 15			
	16 23			
	25 28	2/17/2006	DMF	
UPDATE	9	6/9/06	ME	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
		·	
	_		
See S histori	earch printer	6/9/06	DE

SEARCH (INCLUDING SEAF	NOTES RCH STRATEGY	()
	DATE	EXMR
		<del> </del>